

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT

APPLICANT(S): UGAJIN, Ryuichi et al

NEW DOCKET NO.: 9794353-014

SERIAL NO.:

GROUP ART UNIT: Not yet assigned

DATE FILED: 14 March 2001

EXAMINER: Not yet assigned

INVENTION: Method for Fabricating a Fractal Structure

Hon. Assistant Commissioner for Patents

Washington, DC 20231

S I R:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-1449 form, copies of which are enclosed herewith in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent.

I. OTHER PUBLICATIONS

1. Ling Zhang, Bo Zhang and Gang Chen "Generating and Coding of Fractal Graphs by Neural Network and Mathematical Morphology Methods; IEEE Transactions on Neural Networks, March 1996, Vol. 7 NO. 2, Pages 400-407.
2. Amita Chandra et al, "Fractal Growth in UV-Irradiated DNA: Evidence of Non-Universal Diffusion Limited Aggregation", Physical Review E., April 1995, Vol. 51, No. 4, Pages 51.R2767-51.R2768.
3. G. Albinet and P. Pelce, "Computer Simulation of Neurite Outgrowth", Europhysics Letters, March 1996, Vol. 33, No. 7, Pages 569-574.
4. Kinji Iba et al, "Automatic Map-Drawing Method for Power System Networks Using Fractal Approach; February 1994, Vo. 114-C, No. 2, pages 252-258 (English abstract only).

II. EXPLANATION OF RELEVANCE

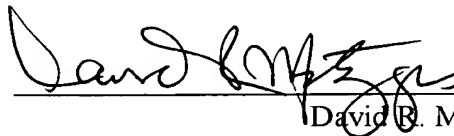
Copies of the above reference together with Form 1449 are submitted herewith in accordance with 37 C.F.R. §1.98. Except as provided, the undersigned does not possess English translations of the non-English references.

SIDS
10-28-01
KPM

The above-identified references were cited in a Japanese Search Report issued on PCT/JP00/04743. A copy of the report is enclosed.

This Information Disclosure Statement complies with 37 C.F.R. §§1.97(b2), as it is being filed within three (3) months of the filing date.

Submitted by,



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